

<b>INFORMATION DISCLOSURE CITATION</b> <i>(Use several sheets if necessary)</i>				Docket No. <b>NEC 05P015</b>	Application Number <b>0599609 - GAU: 2826 10/599,609</b>			
				Applicant(s) <b>OOHASHI et al</b>				
				Filing Date <b>10/03/06</b>	Group Art Unit <b>2814</b>			
<b>U.S. PATENT DOCUMENTS</b>								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME		CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
								
<b>U.S. PATENT APPLICATION PUBLICATIONS</b>								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
<b>FOREIGN PATENT DOCUMENTS</b>								
EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
<b>OTHER DOCUMENTS</b> <i>(Including Author, Title, Date Pertinent Pages, ETC.)</i>								
/S.A./	Fujikata, et al., "Surface Plasmon Enhancement Effect and Its Application to Near-Field Optical Recording", Trans. Magn. Soc. Jpn., Vol. 4, No. 4-2, 2004.							
/S.A./	"Transactions of the Magnetics Society of Japan", Selected Papers from Magneto-Optical Recording International Symposium, Vol. 4, No. 4-2, No. 15 (2004) <a href="http://www.nil.ac.jp/msj2">http://www.nil.ac.jp/msj2</a> , November 2004.							
EXAMINER				/Selim Ahmed/		DATE CONSIDERED		
						12/12/2008		